



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/705,814

Filing Date: November 10, 2003

Applicant: Shinichi Nakamura

Group Art Unit: 2861

Examiner: Lamson D. Nguyen

Title: Method of Determining An Abnormality Of Nozzles In Imaging Apparatus; Imaging Apparatus; Electrooptic Device; Method of Manufacturing Electrooptic Device; and Electronic Equipment

Attorney Docket: 9319H-000586

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed July 12, 2005, please amend the application as follows and consider the remarks set forth below.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.